IN

Docket No.: 063979-0027



IN THE UNITED SPATES PATENT AND TRADEMARK OFFICE

In re Application of

Customer Number: 20277

Gaku SUGAHARA, et al.

Confirmation Number: 3885

Application No.: 10/611,851

Group Art Unit: 2828

Filed: July 03, 2003

Examiner: JACKSON, Cornelius H.

For: NITRIDE SEMICONDUCTOR LASER DEVICE AND FABRICATING METHOD THEREOF

Mail Stop Amendment Transmttal Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith is an Amendment in the above identified application.

No additional fee is required.

Applicant is entitled to small entity status under 37 CFR 1.27

Also attached: Certified copy translation of the Japanese Priority Document (JP 2002-11337)

The fee has been calculated as shown below:

The rec has been calculated	NO. OF CLAIMS	HIGHEST PREVIOUSLY PAID FOR	EXTRA CLAIMS	RATE	FEE	
Total Claims	7	20	0	\$50.00 =		\$0.00
Independent Claims	2	3	0	\$200.00 =		\$0.00
		Multiple dependent claims newly presented			,	\$0.00
		Fee for extension of time				\$0.00
						\$0.00
			Total of Above Calculations			\$0.00

Please charge my Deposit Account No. <u>500417</u> in the amount of \$0.00. An additional copy of this transmittal sheet is submitted herewith.

The Commissioner is hereby authorized to charge payment of any fees associated with this communication or credit any overpayment, to Deposit Account No. 500417, including any filing fees under 37 CFR 1.16 for presentation of extra claims and any patent application processing fees under 37 CFR 1.17.

Respectfully submitted,

McDERMOTT WILL & EMERY LLP

Michael E. Fogart

Registration No. 36,139

Please regognize our Customer No. 20277 as our

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Date: June 28, 2005 WDC99 1102002-1.063979.0027

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THEREOF

AMENDMENT UNDER 37 C.F.R. §1.111

Mail Stop Amendment Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated March 28, 2005, having a three-month shortened statutory period for response set to expire June 28, 2005, please amend the above-identified application as follows: